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Attorney Docket No.: 0180181

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10/11/05*

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Bell, et al.

Art Unit: 1765

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OCT 11 2005

Serial No.: 10/656,467

Examiner: Tran, Binh X.

Filed: 09/05/2003

For: Method for Reducing Resist Height  
Erosion in a Gate Etch ProcessAMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF  
Honorable Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir/Madam:

This is in response to the *Final Office Action* dated September 6, 2005 in the above-referenced patent application. Please enter and consider the following amendments and remarks.